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JUL 19 2006

Docket No.: 300.1126

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

Kei IMAFUJI, et al.

Serial No. 10/661,530

Group Art Unit: 3729

Confirmation No. 7843

Filed: September 15, 2003

Examiner: CAZAN, LIVIUS RADU

For: METHOD FOR PRODUCING WIRING SUBSTRATE

**COMMUNICATION REGARDING INFORMATION DISCLOSURE STATEMENT FILED JULY
10, 2006**

Commissioner for Patents
PO Box 1450
Alexandria, VA 22313-1450
Mail Stop Issue Fee

Sir:

An Information Disclosure Statement (IDS) was inadvertently filed in the subject application on July 10, 2006. The IDS filed July 10, 2006 in the subject application incorrectly contained the header information (i.e., serial number, docket number, filing date, etc.) for the subject application, whereas the IDS should have been filed in a different co-pending application directed to subject matter unrelated to that of the present invention.

Accordingly, please disregard the IDS filed on July 10, 2006 in the subject application.

Respectfully submitted,

STAAS & HALSEY LLP

Date: July 18, 2006

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mitted by facsimile to: Commissioner for Patents,
P.O. Box 1450, Alexandria, VA 22313-1450
on July 19, 2006
By: [Signature]
Date: 7/19/06